

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	23	(semiconductor or silicon\$1) with wafer\$1 with (text\$1 or paragraph\$1)	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/08/04 13:42
L2	1183	(semiconductor or silicon\$1) with wafer\$1 with ((written adj composition) or word\$1 or sentence\$1)	USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/08/04 13:43
L3	0	(semiconductor or silicon\$1) with wafer\$1 with ((written adj composition))	USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/08/04 13:43
L4	358	(semiconductor or silicon\$1) with wafer\$1 with (word\$1 with line\$1)	USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/08/04 13:44

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Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1183	sinha.inv. or lipson.inv. or kluender.inv. or inscript.as.	US-PGPUB; USPAT	OR	OFF	2006/08/04 14:15
L2	2	1 and ((semiconductor or silicon) with (wafer or substrate\$1) with (text\$1 or word\$1) with paragraph\$1)	US-PGPUB; USPAT	OR	OFF	2006/08/04 14:17
L3	3	((semiconductor or silicon) with (wafer or substrate\$1) with (text\$1 or word\$1) with paragraph\$1)	US-PGPUB	OR	OFF	2006/08/04 14:17